IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Shunpei YAMAZAKI et al.

Serial No. 09/894,125

Filed: 06/29/2001

MAY 0 1 2002 For: CRYSTALLINE SEMICONDUCTOR THIN FILM, Art Unit: 2823

Examiner: Unassigned

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail In an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

INFORMATION DISCLOSURE STATEMENT AND

NOTICE OF RELATED APPLICATIONS

Commissioner for Patents and Trademarks Washington, D.C. 20231

METHOD OF FABRICATING THE SAME, SEMICONDUCTOR

DEVICE, AND METHOD OF FABRICATING THE SAME)

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The documents are being submitted within three (3) months of the filing of this application or entry into the national stage of this application, or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R § 1.97(b).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

Eric J. Robinson Reg. No. 38,285

NIXON PEABODY LLP 8180 Greensboro Drive, Suite 800 McLean, Virginia 22102 (703) 790-9110